

<b>Notice of References Cited</b>	Application/Control No. 10/749,637		Applicant(s)/Patent Under Reexamination COLE ET AL.	
	Examiner Daniel Miller		Art Unit 1775	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0161929	08-2004	Son et al.	438/689
*	B	US-6,143,474	11-2000	Shen et al.	430/313
*	C	US-5,187,557	02-1993	Zenke, Masanobu	257/310
*	D	US-6,268,615	07-2001	Liu et al.	257/30
*	E	US-5,710,656	01-1998	Goossen, Keith Wayne	359/291
*	F	US-6,339,281	01-2002	Lee et al.	313/309
*	G	US-6,890,233	05-2005	Hsu, David S. Y.	445/24
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.